



FIG. 1

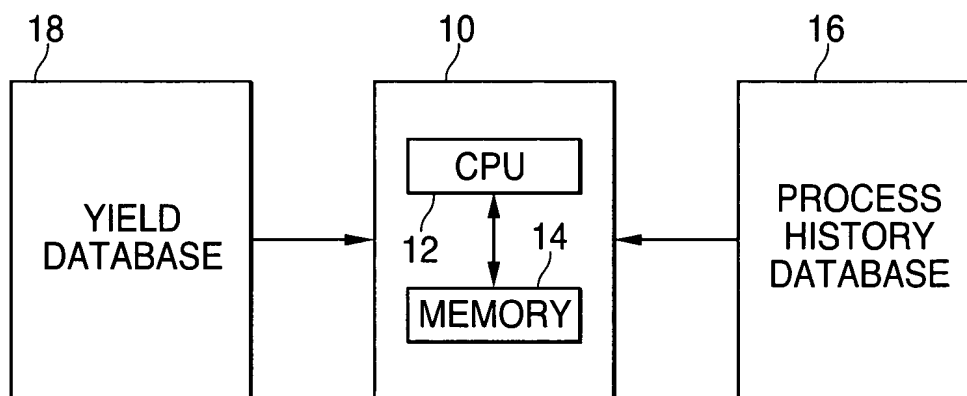


FIG. 2

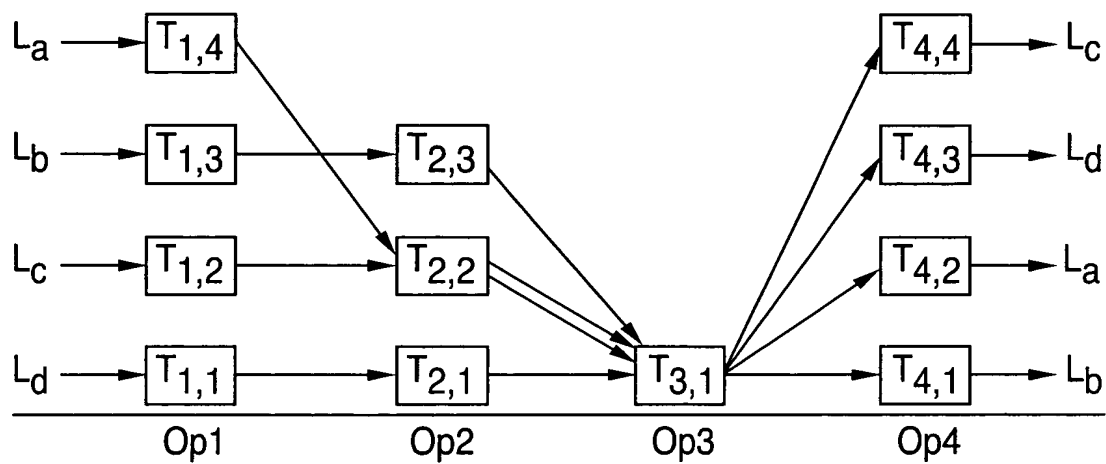




FIG. 3

LOT: L_a		PROCESS FLOW = PF101				Da
Ld_a	OPERATION	Op1	Op2	Op3	Op4	-----
	TOOL	$T_{1,4}$	$T_{2,2}$	$T_{3,1}$	$T_{4,2}$	-----
Yd_a	WAFER	$Wa,1$	$Wa,2$	$Wa,3$	$Wa,4$	-----
	YIELD	$Ya,1$	$Ya,2$	$Ya,3$	$Ya,4$	-----

FIG. 4

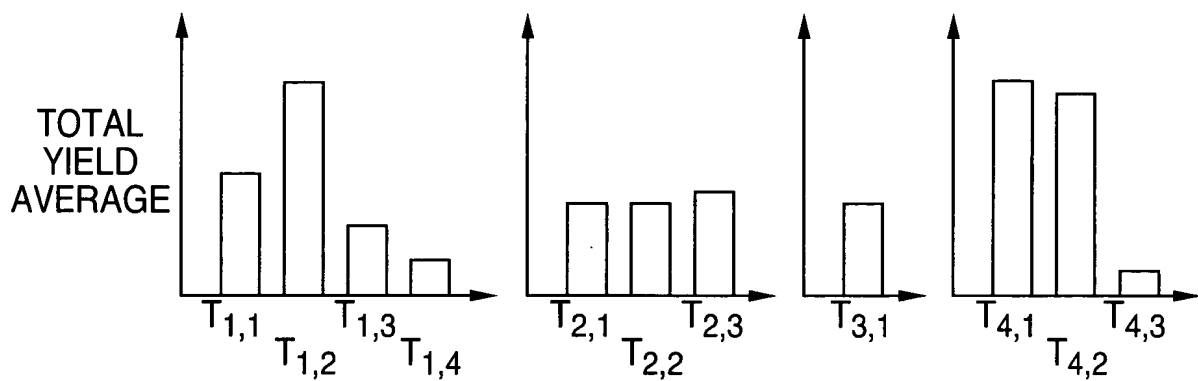




FIG. 5

